

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary.)

(Use several sheets if necessary.)

Local Number (Uphonda.)

SII

Application Number

~~10/06/1959~~

Filing Date

Group Art Unit

1158

U.S. PATENT DOCUMENTS:

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATED	
						YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	<p>D.M. Zhou, et al., "Accelerated Corrosion Tests on Silicon Wafer for Implantable Medical Devices", Proc. of 198th Electrochemical Society Meeting, 363, October 2000</p>
	<p>D.M. Gruen, "Nanocrystalline Diamond Films" Annu. Rev. Mater. Sci., 29 211-59 (199)</p>

EXAMINER: Initial if citation considered; whether or not citation is in conformance with MPEP Section 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-A820
(also form PTO-1449)

Page/Rev.1

Patent and Trademark Office : U. S. DEPARTMENT OF COMMERCE

SHEET 1 OF 2

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary.)

Docket Number (Optional)

S11

Application Number 10/635,632

10/046.158

Applicant(s)

Greenberg, et al.

Filing Date

10/26/2001

Group Art Unit

1615
unknown

•EXAMINER
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

D.M. Gruen, et al. "Buckyball Microwave Plasmas: Fragmentation and Diamond Film Growth", *J. Appl. Phys.*, 75 (3) 1758-63 (1994)

EXAMINER

DATE CONSIDERED

4/29/05

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.